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PATENT APPLICATION
Docket No.: 2522-055
Client Ref. No.: AW9010US/MH

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ju-Cheol SHIN, et al.

Serial No.: 10/816,989 Examiner: Lee, Calvin

Filed: April 1, 2004 Group Art Unit: 2818

Confirmation No.: 2017

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the non-final Office Action, Paper No. 2, mailed on 15 August 2005,
please amend the application as follows.

A Listing of Claims reflecting the current status of the claims begins on page 2 of
this paper.

Remarks/Arguments begin on page 4 of this paper.

An Appendix containing an English translation of the foreign priority document and a
statement that the translation is accurate is attached following page 6 of this paper.